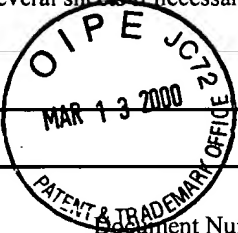



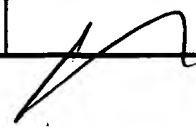
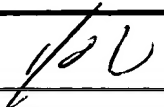
<b>APPLICANT'S ART CITATION</b> (Use several sheets if necessary)								Application <b>09/495,393</b>				OFGS File No. <b>P/2167-158</b>			
								Applicant <b>Albert Kwang-Hwa SUN, et al.</b>							
								Filing Date <b>January 31, 2000</b>				Group Art Unit <b>unknown</b>			



U.S. PATENT DOCUMENTS												
Examiner Initial	Document Number							Date	Name	Class	Sub-class	Filing Date If Appropriate
	5	7	8	7	2	8	3	07/28/98	CHIN et al.			
	5	9	4	6	6	6	2	08/31/99	ETTL et al.			
	5	7	7	4	8	8	3	06/30/98	ANDERSON et al.			
	5	6	9	4	5	5	2	12/2/97	AHARONI			
	4	7	9	9	1	5	6	01/17/89	SHAVIT et al.			

FOREIGN PATENT DOCUMENTS													
	Document Number							Date	Country	Class	Sub-class	Translation	
												Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		

Examiner 	Date Considered 
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.